Information Disclosure Statement U.S. Patent Application No. 09/938,947



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Atty. Docket N	No.: 5010-001	Application No. 25	09/938,	947					
Applicant:	WOUDENBERG et al.								
Filing Date:	August 24, 2001		Group Art Unit:	· 1741 -	1753				
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31M	WO 00/73780 A1 -	12/07/00	WIPO			No			
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BIM	Nanogen document or printout for NanoChip Molecular Biology Workstation, one page, showing we enlargement of 99-site test array (not dated)	Nanogen document or printout for NanoChip Molecular Biology Workstation, one page, showing workstation with enlargement of 99-site test array (not dated)						
Examiner	Brian L Mutschler Date Considered 2/9/1	oij						
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Page 1 of 1 2002 1233 Atty. Docket No. 4573/4660 (5010-001) | Application No. 09/938,947 FORM PTO-1449 (REV 7-80) APPLICANT: Woudenberg, et al. INFORMATION DISCLOSURE STATEMENT Filing Date: August 24, 2001 Group Art Unit: 174+ 1753 **U.S. PATENT DOCUMENTS** DOCUMENT **EXAMINER'S** DATE **SUB-CLASS** NAME CLASS FILING DATE, IF **INITIALS** NUMBER APPROPRIATE 6,174,675 B1. 1/16/01 Chow et al. 435 6 6,267,864 B1 7/31/01 Yadav et al. 205 341 6,416,642 B1 7/9/02 Alajoki et al. 204 451 6,471,841 B1 10/29/02 Nikiforov et al. 204 454 6,476,539 B1 11/5/02 Takeuchi et al. 310 330 FOREIGN PATENT DOCUMENTS DOCUMENT DATE COUNTRY **CLASS** SUB-**TRANSLATION** NUMBER **CLASS** YES OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) Copy of International Search Report from PCT/US02/26657 dated December 9, 2002 **EXAMINER** DATE CONSIDERED

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PTO/SB/08a (05-03)

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